interference search printout

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	199	((substrate or wafer) and chamber and (reaction adj product$1)).clm.	US-PGPUB	OR	OFF	2006/06/06 09:40
L2	126	((substrate or wafer) same chamber and (reaction adj product$1)).clm.	US-PGPUB	OR	OFF	2006/06/06 09:27
L3	68	((substrate or wafer) same chamber same (reaction adj product$1)).clm.	US-PGPUB	OR	OFF	2006/06/06 09:27
L4	139	1 and (remov$4 or reduc$5 or clean$$).clm.	US-PGPUB	OR	OFF	2006/06/06 09:28
L5	61	1 and ((remov$4 or reduc$5 or clean$$) same (reaction adj product$1)).clm.	US-PGPUB	OR	OFF	2006/06/06 09:31
L6	44	1 and ((remov$4 or reduc$5 or clean$$) same (reaction adj product$1) same chamber).clm.	US-PGPUB	OR	OFF	2006/06/06 09:31
L7	22	((semiconductor) same chamber and chamber same (reaction adj product$1)).clm.	US-PGPUB	OR	OFF	2006/06/06 09:41